

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81941

Kenji ITO, et al.

Appln. No.: 10/500,253

Group Art Unit: 1725

Confirmation No.: 8926

Examiner: Maria A. ELVE

Filed: June 25, 2004

For: LASER MATERIAL PROCESSING METHOD

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

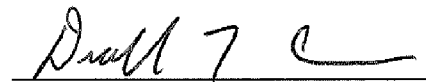
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one months, extending the time for responding to the Office Action of August 23, 2006 to December 26, 2006 (December 23, 2006 falling on a weekend and December 25, 2006 being a holiday).

The statutory fee of \$120.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is also directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account

Respectfully submitted,



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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: December 26, 2006